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# AGREEMENT

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# Lens-based adaptor system for coupling fibre optic to infrared semiconductor lasers

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# Contents

# Page

| Europe   | European foreword                                 |                |
|--|---|----------------|
| Introd   | Introduction                                      |                |
| 1  | Scope   | . 5            |
| 2  | Normative references                              | . 5            |
| 3  | Terms and definitions                             | . 5            |
| 4  | Description of the adaptor and coupling method    | .5             |
| 5  | Performance guidelines                            | .6             |
| 6<br>6.1<br>6.2  | Design requirements and guidelines<br>Cap<br>Lens | .7<br>.7<br>.7 |
| Annex A (informative) Example of use: the MIRACLE Arthroscopy device |   |                |
| Bibliog  | Bibliography                                      |                |

# **European foreword**

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## Introduction

The common solution for coupling an infrared semiconductor laser to an optical fibre is using parabolic mirrors. This solution provides a very low optical loss because of coupling. However, using a parabolic mirror comes with a few disadvantages.

For example, such a coupling is bulky so it makes the infrared semiconductor laser-based devices bigger and difficult to assemble, which renders the final product less affordable. Additionally, if the device contains a parabolic mirror, moving it around might change the performance of the device due to mechanical vibration and might need service. Another drawback is that if an infrared semiconductor laser or fibre must be replaced, a very highly trained technician is needed to perform the replacement and coupling with the parabolic mirror. This leads to an undesirably long repair time.

Therefore, using the parabolic mirror as the fibre coupling method has three disadvantages: the bulky nature of the mirrors, being susceptible to mechanical vibration, and difficulty to service. These problems advised to look for a user-friendly and stable alternative coupling system, which will be highly beneficial for final applications of the devices. This adaptor-based coupling system makes the coupling just a plug-in process which can be done with a short training. Furthermore, using this adaptor makes the system very stable and less sensitive to mechanical vibration and shocks.

The adaptor is a lens-based coupling system, which is attached to the infrared semiconductor laser. For most infrared wavelengths, such lenses are commercially available. The lens adaptor-based coupling technique is a well-established technique for diode laser so implementation of this technique for infrared semiconductor lasers will be a smooth transition from the mirror-based coupling technique. Thus, it could be very easy for the industry to accept it as a standard method. In addition to all the technical benefits of a lens-based adaptor, the overall cost of the devices will be cheaper in comparison to the mirror-based coupling system.

The device covered by this document was firstly developed as a side result of the European, public funded research and innovation project MIRACLE 'Mid-infrared arthroscopy innovative imaging system for realtime clinical in-depth examination and diagnosis of degenerative joint diseases'. The project uses a quantum cascade laser system to create a mid-infrared attenuated total reflection (MIR-ATR) instrument for arthroscopic use. When testing the first prototypes, different performance and design problems were found related to the coupling of the laser units to the fibres, so a new solution was developed. This same solution can be useful in quite different applications in several fields for which infrared semiconductor lasers are increasingly used, such as infrared spectroscopy for different applications (pharma, biotech, environment...), medical equipment, non-metal laser processing, microscopy, laboratory tools for scientific applications, and many more.

## 1 Scope

This document defines design and performance requirements and guidelines for a lens-based coupling adaptor system for fibre optic, intended for coupling fibres to infrared (IR) semiconductor laser sources.

Safety requirements are not covered by this document.

#### 2 Normative references

There are no normative references in this document.

### 3 Terms and definitions

For the purposes of this document, the following terms and definitions apply.

ISO and IEC maintain terminological databases for use in standardization at the following addresses:

- • ISO Online browsing platform: available at <u>https://www.iso.org/obp</u>
- • IEC Electropedia: available at <u>https://www.electropedia.org/</u>

#### 4 Description of the adaptor and coupling method

The adaptor is a single-piece machined element (cap) that fits the IR semiconductor laser housing and is mechanically attached to it. Internally, it incorporates a glued lens that focuses the laser light into the fibre end facet.

The adaptor can be coupled to the IR semiconductor laser by a trained person using a microstage device with three-axis of freedom.

After coupling, the adaptor is fixed to the laser with an adhesive. This assures minimal displacement of the adaptor for reaching the highest possible coupling efficiency.

Figure 1 shows the cross section of the adaptor coupled to an IR semiconductor laser.



#### Key

- 1 adaptor cap
- 2 collimation lens
- 3 IR semiconductor laser
- 4 focusing lens
- 5 thread to fix the fibre

#### Figure 1 — Cross-section of the IR semiconductor laser and adaptor

#### **5** Performance guidelines

Adaptors can be designed for single mode (SM) fibres or multi-mode (MM) fibres. The main difference is the focal spot size on the facet of the attached fibre, which depends on the optical properties of the laser beam and the focusing lens. A general rule for the spot size cannot be given because of the large variety of possible IR semiconductor laser and lens combinations. Normally it is possible to perfectly adapt the system to a selected fibre type and diameter.

The adaptor is not limited to the IR semiconductor lasers and can be used for other types of semiconductor lasers.

The power loss of the IR semiconductor laser after coupling using the adaptor is around 50%, due to reflection and transmission losses of the additional lens. This can be minimized by the use of a properly selected lens material in combination with a dedicated anti-reflection coating on its surface.

This loss is higher in comparison with the coupling through parabolic mirror, but in turn, the assembly is much more robust against mechanical vibrations and much easier to handle. Depending on the wavelength of the IR semiconductor laser, a suitable fibre material should be used to get the lowest possible power loss. Furthermore, the laser power should be calculated high enough to compensate for the total loss.

#### 6 Design requirements and guidelines

#### 6.1 Cap

The cap can be manufactured on different materials. In general, a non-reactive material that is stable for the application environment is recommended.

The dimensions of the cap depend on the application, the laser package and the final device.

Tolerances:

- The general fabrication tolerance should be ISO 2768-m according to EN 22768-1 (ISO 2768-1).
- The rules for the edges should be according to EN ISO 13715.

The cap should also be completely sealed because any external gas or dust could potentially change the lens surface, which could decrease the performance and the lifetime of the device.

Optical grade adhesive should be used to fix the adaptor after coupling with the laser.

#### 6.2 Lens

The lens in the adaptor shall be identical to the collimating lens of the IR semiconductor laser. For IR semiconductor lasers, an aspheric lens shall be used.

The lens should be coated with an anti-reflection layer. The layer reduces power loss as well as interference.

An adhesive with low shrinkage after curing is recommended. The shrinkage of the adhesive could lead to a lower coupling efficiency.

## Annex A

(informative)

## Example of use: the MIRACLE Arthroscopy device

The MIRACLE project designed the first mid-infrared attenuated total reflection (MIR-ATR) arthroscopy system prototype. It enables quantitative evaluation of articular cartilage composition providing a quantitative diagnosis of cartilage injuries and degenerative joint diseases such as osteoarthritis. The principle is based on the molecular vibration of the molecules which constitute the cartilage tissue (for example, amides and proteoglycan). MIRACLE team identified which wavelengths were clinically relevant to distinguish healthy from damaged cartilage.

The device is composed by seven quantum cascade lasers (QCL) providing the required wavelengths for biodiagnostics, an integrated beam guide and combiner for efficient radiation coupling without the need for any dielectric mirrors or refractive gratings, and a handheld, miniaturised MIR-ATR probe with an innovative hook-like design for cartilage assessment. The internal components are assembled into a main unit.

To illustrate the lens-based adaptor system for coupling a mid-infrared laser beam into a fibre, the following figure shows the setup of a single MIR semiconductor laser mounted on a driver unit and connected to an output fibre.



Figure 2 — Setup of a single MIR semiconductor laser mounted on a driver unit and connected to an output fibre



#### Figure 3 — MIRACLE 19" unit containing 7 lasers as depicted in figure 2 and one detector

Further specifications of the device are:

Modular and flexible multi-laser infrared light source and sensing unit for high quality (spectroscopic) measurements in the infrared region, comprising:

- Up to 7 lasers (Interband-Cascade Lasers and/or Quantum-Cascade-Lasers) in TO-3 or TO-66 housings.
- The spectral coverage depends on the laser selection/specifications (typically in the range of 3-12 microns).
- The optical output power and the spectral features depend on the selected lasers.

All 7 internal laser drivers are individually software-configurable:

- The lasers can be driven in CW or pulsed mode.
- With pulse currents from 10 mA to 4.5 A.
- Pulse repetition rates between 10 kHz and 8 MHz.
- Pulse lengths between 10 ns and 255 ns.
- Temperature stabilized (accuracy better 3 mK), with operation temperatures between -10 °C and 40 °C.
- The free space beam of each laser is internally fibre-coupled and available on the front panel of the main unit through corresponding F-SMA output connectors, or alternatively incorporating an internal coupling of all lasers and only one output.
- Suggested core diameter of the fibres is 240 microns (tests were performed with fibre core diameters up to 900 microns).

The implemented radiation detection module:

- Allows the simultaneous detection of all 7 lasers (operated in pulsed mode); one measurement every 25 ms containing a set of 7 values (one for each laser).
- Highly sensitive and low noise radiation detection using a peltier-cooled MCT detector (typical SNR > 2000) / other detector elements upon request.
- The input beam is delivered through a fibre with a F-SMA connector.

The lens-based adaptor was specifically designed to save space, facilitate the coupling process and maintenance, and avoid misalignments and interferences due to probe movement.

The coupling was tested in practice within the MIRACLE project. It shown in comparison to the mirrorbased coupling a suitable performance and a much higher reliability in terms of insensitivity against mechanical shocks and vibrations. e.g., after a movement of the device to another location (lab) there was no need of realignment of the laser beam anymore. Furthermore, the saving of space was a great advantage, which allowed a much more compact design of the device.

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